## CERTIFICATE OF MAILING

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- 1 -

Docket: 0756-958

NOV 15 1995

RESPONSE UNDER 37 CFR 1.116 - EXPEDITED PROCEDURE - EXAMINING GROUP 2500

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE OTTES	`
In re PATENT application of	) \
Shunpei YAMAZAKI et al.	) Art Unit: 2508
Serial No. 08/183,800	) Examiner: M. Saadat
Filed: January 21, 1994	)
For: SEMICONDUCTOR MATERIAL	)
AND METHOD FOR FORMING	) 
THE SAME AND THIN FILM	) Date: November 13, 1995
	) Dawi - 1-4

## **AMENDMENT**

Honorable Commissioner of Patents and Trademarks Washington, D.C. 20231

DEC O A 100

GROUP 2500

Sir:

In response to the Office Action of May 11, 1995, please amend the subject application as follows:

## IN THE CLAIMS:

TRANSISTOR

Please amend claims 23, 25, 27, and 32-35 as follows: